Docket No.: 60188-431

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Akihiko ISHIBASHI, et al.

Confirmation Number: 6491

PATENT PECKING AND TO SERVE SOON

Serial No.: 10/017,389

Group Art Unit: 2818

Filed: December 18, 2001

Examiner: Mai Huong C. Tran

For:

METHOD FOR FABRICATING SEMICONDUCTOR, METHOD FOR FABRICATING

SEMICONDUCTOR SUBSTRATE, AND SEMICONDUCTOR LIGHT EMITTING

DEVICE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop DD Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached form PTO-1449. It is respectfully requested that the reference be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement ("IDS") is supplemental to the IDS filed on August 14, 2003, and includes a partial English translation of JP 10-150245 cited therein.

10/017,389

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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Facsimile: (202) 756-8087 Date: September 17, 2003

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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)																		
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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.